



EXPRESS MAIL NO. EV530952750US

**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE - EXAMINING GROUP 2810**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Pietro Erratico et al.  
Application No. : 10/712,211  
Filed : November 12, 2003  
For : PROCESS FOR FORMING A BURIED CAVITY IN A  
SEMICONDUCTOR MATERIAL WAFER AND A BURIED  
CAVITY

Patres. and Mail  
**BOX AF**

Examiner : George C. Eckert II  
Art Unit : 2815  
Docket No. : 854063.618D1  
Date : July 26, 2005

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE/AMENDMENT UNDER 37 CFR 1.116**

Commissioner for Patents:

In response to the Office Action dated April 26, 2005, please amend the application as follows:

**Amendments to the specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.

*OKAY TO ENTER AMENDMENT,  
AW 8/5/05*